Electronic Acknowledgement Receipt				
EFS ID:	6020439			
Application Number:	10586788			
International Application Number:				
Confirmation Number:	1598			
Title of Invention:	Plasma Excited Chemical Vapor Deposition Method Silicon/Oxygen/ Nitrogen-Containing-Material and Layered Assembly			
First Named Inventor/Applicant Name:	Zvonimir Gabric			
Customer Number:	48154			
Filer:	Ira Stuart Matsil/Julie Russell			
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Attorney Docket Number:	2006 VJ 33543 US			
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Application Type:	U.S. National Stage under 35 USC 371			

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Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.
1		061/122542 Amondonated	241626		
1	06VJ33543_Amendment.pdf	fbb65b1a03c4f46d910c3bb8b5ad7267d92 47362	yes	8	
	Multip	part Description/PDF files in a	zip description	<u>'</u>	
	Document De	Document Description		End	
	Amendment/Req. Reconsideration-After Non-Final Reject		1	1	
	Claims		2	6	
	Applicant Arguments/Remarks Made in an Amendment		7	8	
Warnings:					
Information:					
2	06VJ33543_IDS.pdf	128824	yes	2	
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	Document De	Document Description		End	
	Transmittal Letter		1	1	
	Information Disclosure Statement (IDS) Filed (SB/08)		2	2	
Warnings:					
Information:					
3 Fee Worksheet (PTO-875)	fee-info.pdf	30565	no	2	
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## New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

## National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

## New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.